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Paper No. 6

Kathryn A. Marra Delphi Technologies, Inc. Legal Staff PO Box 5052 Mail Code: 480-414-420 Troy, MI 48007-5052

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OFFICE OF PETITIONS

In re Application of Martin Dirk Skirha et al. Application No. 09/747,286

Filed: December 21, 2000

For: Instrument Panel with Integral Hidden Door Cover and Method of In-Process Manufacture Thereof

DECISION ACCORDING STATUS

UNDER 37 CFR 1.47(a)

This is a decision on the petition under 37 CFR 1.47(a) filed July 20, 2001.

The petition under 37 CFR 1.47(a) is granted.

Petitioner has shown that the non-signing inventor has refused to join in the filing of the above-identified application.

The above-identified application and papers have been reviewed and found in compliance with 37 CFR 1.47(a). This application is hereby accorded Rule 1.47(a) status.

As provided in Rule 1.47(a), this Office will forward notice of this application's filing to the non-signing inventor at the address given in the petition. Notice of the filing of this application will also be published in the Official Gazette.

After the mailing of this decision, the file will be forwarded to Office of Initial Patent Examination for preexamination processing.

Telephone inquiries regarding this decision should be directed to Latrice Bond at (703) 308-.

6911.

Latrice Bond
Paralegal Specialist
Office of Petitions

Office of the Deputy Commissioner for Patent Examination Policy

Frances Hicks

Lead Petitions Examiner

Office of Petitions

Office of the Deputy Commissioner for Patent Examination Policy